

Electron Source Status update

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Albuquerque, Sept. 29 – Oct.3, 2009

Global Design Effort

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Current e- source location



Drawing provided by Vic Kuchler of FNAL (8/21/09)

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Activities

• Design

- Integration into overall layout (CFS group)
- Spin rotation options at lower energy
- R&D
 - Source Laser System
 - Polarized Photocathodes
 - Polarized Gun
 - CLIC Collaboration
- Cost

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- Largely unchanged
- Main cost drivers are CFS and technical systems (e.g. RF configuartion, cryogenic systems)
- No modification of beam line components

 \rightarrow K. Moffeit

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 \rightarrow J. Sheppard

Laser System Development



- Most components in place
- Problem with pump laser for Ti:Sapphire amplifier
- Consider replacement
- Evaluating options (commercial systems)

Polarized Photocathode Work

- Continue work at SLAC's CTS and GTF
- <u>GaAs/GaAsP</u>, AllnGaAs/AlGaAs
- Promising results for Alkalide Co-deposition techniques
- Collaboration with our main cathode supplier SVT through SBIR projects
- Address issues of polarization measurements (GTF Mott polarimeter)

DC Gun development at Jlab

- Inverted Gun installed at CEBAF
- Currently 100 125 kV



Conventional geometry: cathode electrode mounted on metal support structure



Replace conventional ceramic insulator with "Inverted" insulator: no SF6 and no HV breakdown outside chamber

Nb electrodes

- Comissioning of second inverted gun with Nb electrodes – in progress
- Single Crystal Niobium:
 - Capable of operation at higher voltage and gradient
- Buffer chemical polish (BCP) much easier than diamond-paste-polish





Inverted Gun at voltage > 100kV?



- Presently limited to 150kV at CEBAF
- 150 kV would provide "safe" gradient and likely markedly better transmission,

ir iit Gun design optimization



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Gun Work Summary

- New Inverted Gun works, a viable design for ILC...a good way to go...FEL pursuing similar approach for 500kV gun....
- Spare Inverted Gun nearly complete, to provide beam at Test Cave by November. Will push operating voltage > 100kV
- Field emission tests continue, but slowly.
- During FY2010...

Model the ILC electrode Identify quiet electrodes to 10MV/m Demonstrate reliable 140kV operation Push voltage to ~ 200kV

• Future: Mate Jlab gun and SLAC laser system to demonstrate ILC beam



CLIC collaboration (electron source)

- Successful Demonstration of CLIC polarized source parameters using (evolved) SLC source
 - Beam Charge
 - Surface Charge Limit
 - Electron Polarization
 - Cathode Lifetime
- Details by John Sheppard



Recent and upcoming Milestones (I)

Source Laser

- 1) ILC formatted laser bunch pattern.
- 2) Installation of KM Labs SBIR laser system.
- Full laser system operational. 3)

Photocathode R&D

- 1) Investigate the effects of doping profile on QE, polarization, and charge limit in GaAs cathodes.
- Study effects of ion back bombardment on QE 2) lifetime.

Gun R&D

- Reliable 200kV load locked gun Progress towards ~ 350kV design
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Dec. 08 Done Dec. 09 Mar. 10

Ongoing

Ongoing

2009 2010 (2011)



Recent and upcoming Milestones (II)

Integrated source system development

- Generate electron beam with ILC bunch train parameters Mar. 10 1) in SLC gun.
- Build ILC polarized electron source in conjunction with Dec. 10 2) Jefferson Laboratory.
- Demonstrate ILC specification polarized electron source. Dec. 11 3)

CLIC Source Collaboration

- Demonstration of CLIC electron source beam with 1) existing equipment: Sep. 09, Done Sep. 09, Done
- Modeling of CLIC source rf capture: 2)

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Summary

- Main Activities are of R&D nature.
- All of our 'focus' areas are progressing towards the ILC beam demonstration
- Most severe problem currently is 'stall' of laser development due to pump laser failure.
- Very successful use of SLAC's facilities for CLIC source development.